

Citations for Ion : **Er**

Pub. Year	Authors, Title, Journal Citation and Comments	Citation Numb
1975	Kiselevich, M. Lyatushinski, A. Zhuk, V. Osipenko, B. P. 'Implantation of Heavy Ions into Silicon Single Crystals' <i>Fiz. Tverd. Tela, 17, 1080-84 (1975). [Engl. Trans. Sov. Phys. Solid State, 17, 687-89 (1975).</i> <i>Comment : R, dR. 45 keV Sr, Ba, Ce, Nd, Eu, Gd, Tb, Er, Tm, Lu -> Si (Cryst. Chann. And Random)</i>	1975-Kise
1978	Combasson, J. L. Farmery, B. W. McCulloch, D. Neilson, G. W. Thompson, M. W. 'Heavy Ion Ranges in Aluminum and Silicon' <i>Rad. Effects, 36, 149-156 (1978)</i> <i>Comment : R, dR. 20-250 keV Cs, La, Pr, Eu, Tb, Dy, Ho, Er, Lu, Hf, Pt, Au, Tl, Pb, Bi -> Al; Sm, Eu, Gd, Tb, Dy -> Si</i>	1978-Comb
1988	Grande, P. L. Fichtner, P. F. P. Behar, M. Zawislak, F. C. 'Range Parameters of Heavy Ions Implanted into C Films' <i>Nucl. Inst. Methods, B33, 122-124 (1988)</i> <i>Comment : R, dR. Pb, Yb, Er, Cu (10-200 keV) -> C</i>	1988-Gran2